

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 8, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG797670770

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.52 - 6.55 X 4.06 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.06 CARAT

E

VS 1

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

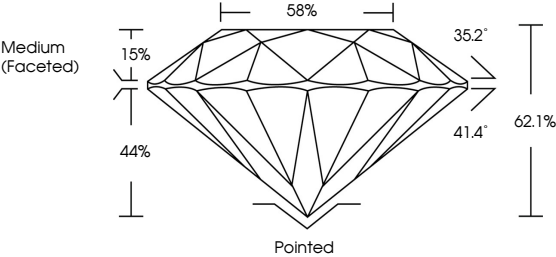
EXCELLENT

NONE

 LG797670770

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium (Faceted)

58%

35.2°

41.4°

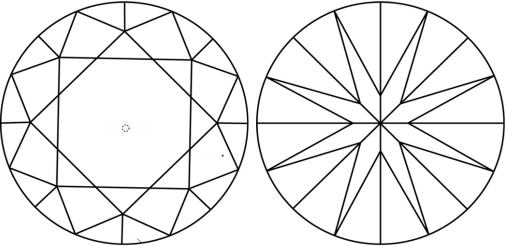
62.1%

15%

44%

Pointed

CLARITY CHARACTERISTICS

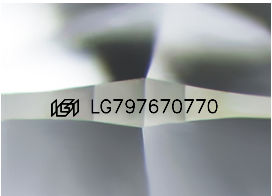


KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

Sample Image Used



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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IGI

May 8, 2026

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ROUND BRILLIANT

6.52 - 6.55 X 4.06 MM

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium (Faceted)

1.06 CARAT

E

VS 1

IDEAL

62.1%

58%

Pointed

EXCELLENT

EXCELLENT

NONE

 LG797670770

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

None

None

None

None

None

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